

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :	Yasuhiko KOJIMA, et al.	CONFIRMATION NO.:	1461
Serial No.:	10/591,476	Art Unit:	1715
Filed:	September 1, 2006	Examiner:	Mandy C. Louie
For:	COPPER FILM DEPOSITION METHOD		

SIXTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the document noted in the European Office Action issued on November 21, 2011 for EP Application No. 05710705.4 being submitted herewith. No copy of the U.S. document cited therein is enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
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